



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

August 27, 2026

IGI Report Number

LG833656586

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

OVAL BRILLIANT

Measurements

11.81 X 8.08 X 5.11 MM

GRADING RESULTS

Carat Weight

3.08 CARATS

Color Grade

E

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG833656586

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

LG833656586

Report verification at igi.org

PROPORTIONS

Medium To Slightly Thick (Faceted)

14%

61%

46%

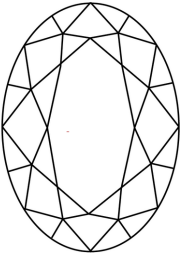
63.2%

Pointed



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included

IGI



© IGI 2020, International Gemological Institute

FD - 10 20

LABORATORY GROWN DIAMOND REPORT



August 27, 2026

IGI Report Number

LG833656586

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

OVAL BRILLIANT

Measurements

11.81 X 8.08 X 5.11 MM

GRADING RESULTS

Carat Weight

3.08 CARATS

Color Grade

E

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

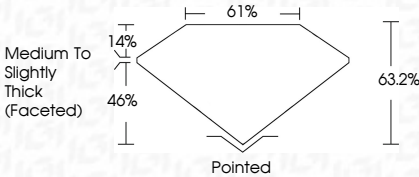
Fluorescence

NONE

Inscription(s)

 LG833656586

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



August 27, 2026

IGI Report No LG833656586

OVAL BRILLIANT

11.81 X 8.08 X 5.11 MM

3.08 CARATS

E

VVS 2

63.2%

61%

Medium to Slightly Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

 LG833656586

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

None

Excellent

Excellent

None

None

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa